

Notice of References Cited	Application/Control No. 10/575,347		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner JENNIFER F. HU		Art Unit 2821	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,573,867 B1	06-2003	Desclos et al.	343/700MS
*	C	US-2005/0275595 A1	12-2005	Endo et al.	343/702
*	D	US-2006/0244668 A1	11-2006	Iellici et al.	343/729
*	E	US-7,345,631 B2	03-2008	Kim et al.	343/700MS
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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